PATENT

THE UNITED STATES PATENT AND TRADEMARK OFFICE

the application of: Hyun-Eun KIM, et al.

Serial No.: 09/469,317

Group Art Unit: 2712

Filed: Dec. 22, 1999

Examiner: Not Yet Assigned

For: APPARATUS FOR CONVERTING ANALOG IMAGE DATA INTO PLO

IMAGE DATA IN CMOS IMAGE SENSOR

FEB 11 2002

INFORMATION DISCLOSURE STATEMENT

Technology Center 2600

Honorable Commissioner of Patents Washington, DC 20231

February 7, 2002

Sir:

As a means of complying with the duty of disclosure under 37 CFR §1.56, and in accordance with 37 CFR §§1.97 and 1.98, Applicant(s), through the undersigned attorney, submits this Information Disclosure Statement. The patents, publications or other information submitted herewith are listed on the attached Form PTO-1449 and copies are attached.

In accordance with 37 CFR \$1.97(b)(3), this Information Disclosure Statement is being filed before the mailing date of a first Office Action on the merits of the above-identified application.

The patents and publications listed on Form PTO-1449 were cited in a Netherlands Search Report mailed not more than three months ago in a counterpart Netherlands patent application. A copy of the Netherlands Search Report is enclosed.

Certification in accordance with 37 CFR § 1.97(e) is included herein. Accordingly, it is respectfully submitted that no fee is required by the filing of this Information Disclosure Statement. Should any fee be required, please charge such fee to Deposit Account No. 06-1358. A duplicate copy of this paper is enclosed.

CERTIFICATION

It is hereby certified that each item of information contained in this Information Disclosure Statement was cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.

Respectfully submitted,

JACOBSON HOLMAN, PLLC

Yoon S Ham

By:

Registration No. 45,307

400 Seventh Street, N.W. Washington, DC 20004 (202) 638-6666

Atty. Dkt. No.: P64146US0

YSH:ecl

Information Disclosure Statements

U.S. Patent Application No. 09/469,317 Your Ref. No. 11349-P64146US0 Our Ref. No. <u>P99HA009/US</u>

Issued Date by Netherlands Patent Office : January 7, 2002 Received Date from our foreign law firm : January 16, 2002

Reference Nos: EP 2325585 A, US 5982318